



Docket No.: 0756-7295 *JFW*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE PATENT application of)
Koichiro TANAKA)
Serial No. 10/827,402) Group Art Unit: 2891
Filed: April 20, 2004) Examiner: Christian Wilson
For: BEAM IRRADIATION APPARATUS, BEAM)
IRRADIATION METHOD, AND METHOD FOR)
MANUFACTURING THIN FILM TRANSISTOR)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
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P. O. Box 1450, Alexandria VA 22313-1450, on October 3, 2005

Henry A. Davis

REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

[Signature]

Eric J. Robinson
Reg. No. 38,285

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